We are so pleased to announce the recipients of AM-FPD '18 Award. They will be presented the award in the Opening Session of AM-FPD '19 on July 2, 2019.

AM-FPD '18 Best Paper Award

3-2 High-Performance Solution-Processed Thin-Film Transistors Using Fluorine-Doped Aqueous Metal Oxides

Masashi Miyakawa, Mitsuru Nakata, Hiroshi Tsuji, Yoshihide Fujisaki, NHK Sci. & Technol. Res. Labs., Japan

AM-FPD '18 Poster Paper Award

P-16 Flexible Thin-Film Transistors with Vertical In-Ga-Zn-O Channel Using Atomic-Layer Deposition on Poly(Ethylene Naphthalate) Substrate

Hyeong Rae Kim¹, Ji-Hee Yang¹, Gi-Heon Kim², Sung-Min Yoon¹, ¹Kyung Hee Univ., Korea, ²Electronics & Telecommunication Res. Inst., Korea

AM-FPD '18 Student Award

So-Yeong Na, Kyung Hee Univ., Korea

5-3 Characterizations of Charge-Trap Memory Thin-Film Transistors Using HfO₂/ZnO Stack-Structured Charge-Trap Layer Controlled by Atomic Layer Deposition

AMFPD '18-ECS Japan Section Young Researcher Award

Taehwan Jun, Tokyo Inst. of Technol., Japan,

L-1 Solution-Processable P-type Transparent Amorphous Semiconductor for Flexible Electronics